

U.S. Department of Commerce, Patent and Trademark Office				Attorney Docket No.: 004-8063		
				Application No.: 10/686,471		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant(s): Mu-Jing Li et al.		
(Use several sheets if necessary)				Filing Date: October 15, 2003		
				Group Art Unit: 2825		
				Date Submitted: April 26, 2004		
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Examiner <i>Murphy</i>		Date Considered 1-7-06				
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